

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on 8/3/2009 has been entered.

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Kevin Bastuba on 8/13/2009.

The application has been amended as follows:

IN THE SPECIFICATION:

On page 1, the following phrase has been inserted after the title of the invention;
-- CROSS REFERENCE TO RELATED APPLICATIONS

This patent application is the U.S. National Stage of International Application No. PCT/FR05/00445, filed February 24, 2005, which claims the benefit of France Application No. 0402063 filed February 27, 2004.

BACKGROUND OF THE INVENTION --;

On page 7, the following phrase has been inserted after the end of line 30;

-- BRIEF DESCRIPTION OF DRAWING -- ; and

On page 9, the following phrase has been inserted after the end of line 15;

-- DETAILED DESCRIPTION OF THE INVENTION -- .

Allowable Subject Matter

Claims 1-22 are allowable over the prior art of record.

The following is an examiner's statement of reasons for allowance: one of ordinary skill in the art would not have been motivated to modify the teaching of Parmentier et al. to further includes, among other things, the specific of a superconductive highly inductive component comprising a line segment constituting a conducting or superconducting layer within a stack of thin layers of alternately an electrically insulating material and a superconductive material where the stack including a plurality of layers of the insulating material and a plurality of layers of the superconductive material as set forth in claims 1, 14, 20 and 21

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to James Cho whose telephone number is 571-272-1802. The examiner can normally be reached on Monday-Friday 6:30 AM - 3:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Rexford Barnie can be reached on 571-272-7492. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

/James H. Cho/
Primary Examiner
Art Unit 2819